

PATENT
37904-0033.1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tohru Segawa et al.
U.S. serial no. : 10/664,272
Filed : September 15, 2003
For : SILICA GLASS JIG FOR SEMICONDUCTOR
INDUSTRY AND METHOD FOR PRODUCING SAME
Group art unit : 1731
Examiner : unknown

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on: December 24, 2003.

Andrew L. Tiajolloff
Name of Applicant, Assignee
or Registered Representative


Signature

December 24, 2003
Date of Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

SIR:

Applicant submits herewith a PTO form SB/08A listing references with copies of the non-U.S. patent references also enclosed. Submission of these references should not be seen as an admission that the references are relevant or that they are prior art to this application.

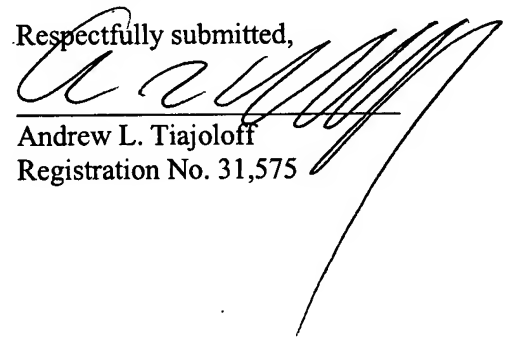
Entry of these references in the prosecution file is respectfully requested.

It is not believed that any fee is required for consideration of these references, but if a fee is required, please deduct it from deposit account 501659.

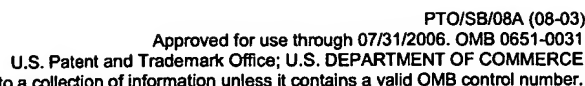
Should any questions arise, the Examiner is invited to telephone attorney for applicants at 212-490-3285.

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Respectfully submitted,


Andrew L. Tiajolloff
Registration No. 31,575

PTO/SB/08A (08-03)

**Complete if Known**

(Use as many sheets as necessary)

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Application Number	10/664,272
Filing Date	September 15, 2003
First Named Inventor	Tohru Segawa et al.
Art Unit	1731
Examiner Name	Unknown
Attorney Docket Number	37904-0033.1

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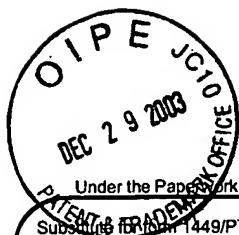
FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear
		Country Code ³ *Number ⁴ *Kind Code ⁵ (if known)	MM-DD-YYYY		
		JP 10-59744	03/03/1998	Shin-Etsu Quar.	
		JP 11-106225	04/20/1999	Shin-Etsu Quar.	
		JP 11-130451	05/18/1999	Shin-Etsu Quar.	

Date
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Examiner Name	Unknown
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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Patent Abstracts of Japan. Publication no. 07267679 A, October 17, 1995. Shin-Etsu Quartz Products Co. Ltd.	
		Patent Abstracts of Japan. Publication no. 10-273339, October 13, 1998. Shin-Etsu Quartz Products Co. Ltd.	
		Patent Abstracts of Japan. Publication no. 10-059744, March 3, 1998. Shin-Etsu Quartz Products Co. Ltd.	
		Patent Abstracts of Japan. Publication no. 10-059744, March 3, 1998. Shin-Etsu Quartz Products Co. Ltd.	
		Patent Abstracts of Japan. Publication no. 11-106225, April 20, 1994. Shin-Etsu Quartz Products Co. Ltd.	
		Patent Abstracts of Japan. Publication no. 11-130451, May 18, 1999. Shin-Etsu Quartz Products Co. Ltd.	
		Patent Abstracts of Japan. Publication no. 2000-021888, January 21, 2000. Shin-Etsu Quartz Products Co. Ltd.	
		O'HANLON. JOHN F. Advances in Vacuum Contamination Control for Electronic Materials Processing. Journal of Vacuum Svcs. Jul/Aug. 1987.	

Examiner Signature		Date Considered	
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